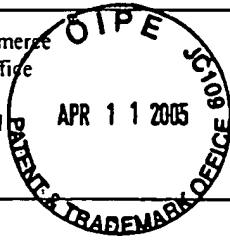


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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
						Abs.	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
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